

DOCKET NO. : LIN 13-38

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Wen Lin, et al.

Serial No.: N/A

Filed: Herewith

For: SEMICONDUCTOR DEVICE HAVING A DOPED LATTICE
MATCHING LAYER AND A METHOD OF MANUFACTURE
THEREFOR

Group No.: N/A

Examiner: N/A

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

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INFORMATION DISCLOSURE STATEMENT

Pursuant to the duty of disclosure under 37 C.F.R. § 1.56, Applicant submits this statement. This submittal is made in accordance with 37 C.F.R. §§ 1.97 and 1.98 and § 609 of the Manual of Patent Examining Procedure. The patents, publications and other information herein are listed below and on the attached Form PTO-1449. Copies of the listed references are submitted herewith.

U.S. Patent No.

Inventor

Date

4,378,259

Hasegawa et al.

March 29, 1983

References:

U.S. Serial No. 10/003,873 filed on October 24, 2001; entitled "SEMICONDUCTOR DEVICE HAVING A DOPED LATTICE MATCHING LAYER AND METHOD OF MANUFACTURE THEREFOR" to Wen Lin, et al.; Allowed January 13, 2004.

Applicant hereby expressly reserves the right to swear behind the effective dates of any of the above Patents and to question the relevance and materiality of the Patents and Publications listed herein, in whole, in part, or in combination, subsequent to filing this Information Disclosure Statement.

Respectfully submitted,

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Substitute for form 1449/PTO			<div>Complete if Known</div> <table border="1"> <tr> <td>Application Number</td> <td>N/A</td> </tr> <tr> <td>Filing Date</td> <td>Herewith</td> </tr> <tr> <td>First Named Inventor</td> <td>Wen Lin, et al.</td> </tr> <tr> <td>Art Unit</td> <td>N/A</td> </tr> <tr> <td>Examiner Name</td> <td>N/A</td> </tr> <tr> <td>Attorney Docket Number</td> <td>LIN 13-38</td> </tr> </table>		Application Number	N/A	Filing Date	Herewith	First Named Inventor	Wen Lin, et al.	Art Unit	N/A	Examiner Name	N/A	Attorney Docket Number	LIN 13-38
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Sheet	1	of	2													

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Sheet	2	of	2	Attorney Docket Number	LIN 13-38

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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